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CONFIRMATION NO. 4496

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
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RULE						
APPLICANTS Noriyoshi Sato, Miyagi, JAPAN; Takeshi Taniguchi, Tokyo, JAPAN; Hiroshi Mase, Ibaraki, JAPAN; Shuitsu Fujii, Hiroshima, JAPAN; Tamiya Fujiwara, Iwate, JAPAN;						
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/16887 12/26/2003						
** FOREIGN APPLICATIONS ***** JAPAN 2002-379963 12/27/2002						
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/16/2006						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No		JAPAN	18	21	8
Verified and	/CARIDAD EVERHART/	Initials				
Acknowledged	Examiner's Signature					
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES						
TITLE Plasma generator, ozone generator, substrate processing apparatus and manufacturing method of semiconductor device						
FILING FEE RECEIVED 2080	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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